



-1-

IFW AF/2877
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Jeffrey E. McAninch

Application No.: 10/027,385

Filed: December 21, 2001

For: PURGE SYSTEM FOR OPTICAL
METROLOGY TOOL

Confirmation No.: 1135

Group Art Unit: 2877

Examiner: R.A. Rosenberger

**CHANGE OF ATTORNEY OR AGENT'S
ADDRESS IN APPLICATION
(37 CFR 1.8(a))**

353 Sacramento Street, Suite 2200
San Francisco, CA 94111
(415) 772-4900

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited
with the United States Postal Service as First Class Mail in an
envelope, addressed to: Commissioner for Patents, P.O.
Box 1450 Alexandria, VA 22313-1450 on June 8, 2004.

STALLMAN & POLLOCK LLP

Dated: 06/8/2004

By:

Georgia K. Smith
Georgia K. Smith

Sir:

Please send all correspondence for this application to:

STALLMAN & POLLOCK LLP
Attn: Michael A. Stallman
353 Sacramento Street, Suite 2200
San Francisco, CA 94111
Customer No.: 28584

Please direct all telephone calls to:

Michael A. Stallman
Telephone: (415) 772-4900
Facsimile: (415) 398-2890

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: June 8, 2004

By: *Jason D. Lohr*
Jason D. Lohr (Reg. No. 48,163)

Attorneys for Applicant(s)

Atty Docket No.: TWI-13510